OPTO MECHANICS SCAN BLOCK C10516

Compact scan head for easy assembly into a system

OVERVIEW

The C10516 scan block is an optical block that combines galvano scanners with a telecentric f θ (F-theta) lens designed for laser beam scanning in the visible range. Coupling the C10516 to other optical blocks allows forming a measurement system for laser scanning fluorescence microscopes, reflecting microscopes, and even confocal microscopes. The 21.5 mm diameter observation area allows making wide-range sample observations. High magnification images can be observed with a photomultiplier tube by attaching the scan block to the C-mount port of a commercially available microscope.



 Laser scanning microscopes
Confocal laser scanning microscopes (Example) Biological microscopes Industrial microscopes DNA chip and protein chip readers



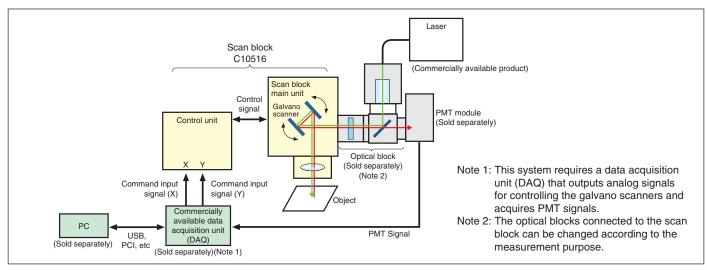
Left: Scan block main unit, Right: Control unit

FEATURES

- ●2D scan by two galvano scanners
- Contains a telecentric $f\theta$ (F-theta) lens
- •Wide observation area of 21.5 mm diameter
- •High-magnification observations in combina-
- tion with a microscope objective lens
- Covers a wide spectral range

CONFIGURATION

The C10516 consists of a scan block main unit and a control unit. Two galvano scanners and a telecentric $f\theta$ lens are built into the scan block main unit. The control unit contains a driver board for driving and controlling the galvano scanners.

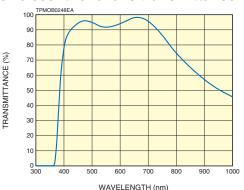




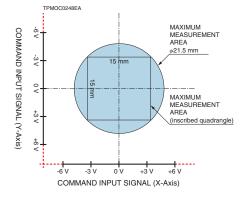
SPECIFICATIONS

	Items		Specifications	Units
Power input			AC100 to AC240	V
Power consumption Max.		85	VA	
	Design wavelength ^(A)	488 to 632	nm	
	Transmittance (≥90 %)	440 to 720	nm	
	Focal length	50	mm	
Optical characteristics	Maximum measurement area	φ21.5	mm	
	Maximum measurement area (inscribed c	15 × 15	mm	
	Scan angle of maximum measuren	±12.4	deg.	
	Input beam aperture	φ4	mm	
	Working distance	20	mm	
	Resolution	80	Lp/mm	
Galvano	Maximum command input sig	±6	V	
scanner	Scan length per command input	2.5	mm/V	
characteristics	Maximum scan speed	400	Hz	
Characteristics	Fill fraction ^D	≥70	%	
Mirror	Coating		AI	—
characteristics	Damage threshold		100 to 150	W/cm ²
Operating amb	Operating ambient temperature		0 to +45	°C
Storage tempe	Storage temperature		-10 to +50	°C
Operating amb	Operating ambient humidity ^(E)		Below 80	%
Storage humid	ty [©]		Below 85	%





Command input voltage and observation field of view



A The telecentric f0 lens is designed with three wavelengths (488nm, 532nm, 632nm).

BVoltage supplied to the X and Y axis scanner signal input on the control unit.

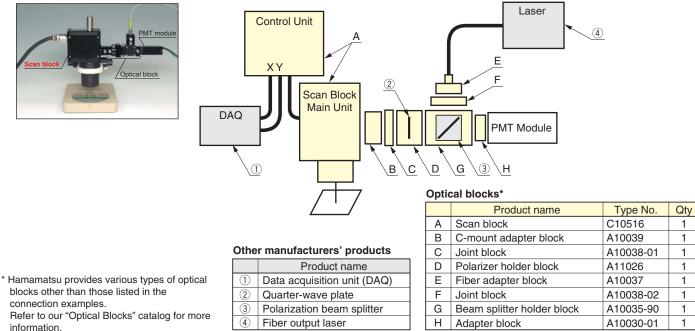
©Scan length at the field-of-view position for command input signal voltage that is supplied to the galvano scanners. ©Percentage of constant velocity movement zone where the galvano scanner enters the measurement area. (E)No condensation

CONNECTION EXAMPLES

The optical system can be assembled by connecting the necessary optical blocks to the light input-output port on the scan block. The optical system connected to the scan block differs according to the object to be measured. Use the following examples as a general reference to connect optical blocks (sold separately) and commercially available optical components to the scan block.

1Reflected light detection

Attaching other optical blocks to the light input port of the scan block allows observations in an area of 15 mm × 15 mm.

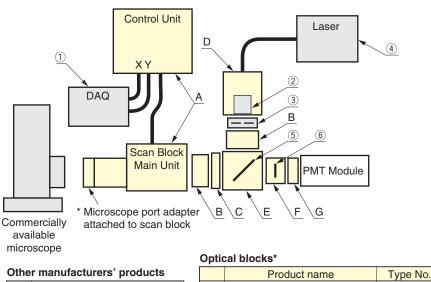


TPMOC0249EA

2Fluorescence detection using scan block attached to microscope port

The scan block can be connected to the C-mount camera port of a commercially available microscope via the microscope port adapter that comes with the scan block. This system allows fluorescence image acquisition by laser scanning.





	Product name	Α	Scan block
D	Data acquisition unit (DAQ)	В	C-mount adapter block
2)	Infinity-corrected objective lens	С	Joint block
3)	Iris diaphragm barrel	D	Beam aligner block
1)	Fiber output laser	Е	Dichroic block
5)	Dichroic mirror	F	Filter block
6	Filter	G	Adapter block

TPMOC0250EA

Qty

1

2

1

1

1

1

C10516

A10039

A10760

A10038-01

A10034-90

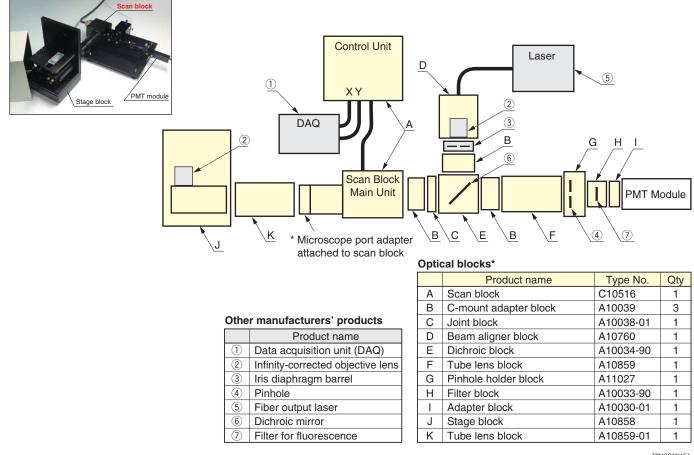
A10033-90

A10030-01

③Fluorescence detection using confocal optical system

(2) (3) (4) (5)

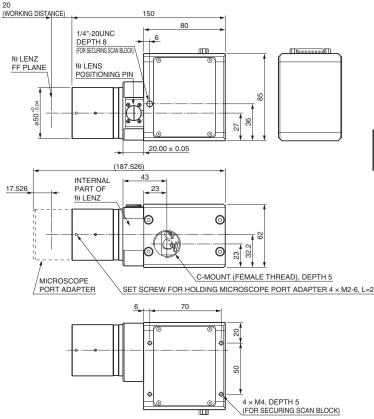
Using the scan block with a stage block and other optical blocks allows building a microscope system.



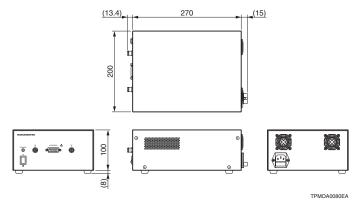
TPMOC0251EA

DIMENSIONAL OUTLINES (Unit: mm)

Main unit



Control unit



<RELATED PRODUCTS>

Sample software

Hamamatsu provides sample software for acquiring images using the scan block. This software was developed with National Instruments LabVIEW 2011 and so the software program was created assuming that a data acquisition unit (DAQ) of National Instruments is used. We also offer the program source free of charge to allow you to change the program or add functions as needed.

[Operating conditions] The following items must be installed:

LabVIEW 2011 or later NI-DAQmx NI-IMAQ 4.6.4 or later

Please contact us when you need this sample software.

Data acquisition unit (DAQ) (commercially available product)

A data acquisition unit (DAQ) is required to operate the scan block. Using a commercially available data acquisition unit (DAQ) helps you operate the scan block. Select the DAQ with specifications that match your application.

[Recommended specifications]

input channels (bits) (S/second) output channels (bits) (S/second)	oomoling	1/0
	sampling	I/O
1 or more ^(a) 12 or more 1 M or more 2 12 or more 1 M or more	a	Ø

(a)When acquiring images from multiple channels, we recommend using a simultaneous sampling DAQ. If a multiplexer type is used, the acquired images will shift in time. bCounter input will be needed when using photon counting to acquire images.

Subject to local technical requirements and regulations, availability of products included in this promotional material may vary. Please consult with our sales office. Information furnished by HAMAMATSU is believed to be reliable. However, no responsibility is assumed for possible inaccuracies or omissions. Specifications are subject to change without notice. No patent rights are granted to any of the circuits described herein. ©2017 Hamamatsu Photonics K.K.

HAMAMATSU PHOTONICS K.K. www.hamamatsu.com

HAMAMATSU PHOTONICS K.K., Electron Tube Division

314-5, Shimokanzo, Iwata City, Shizuoka Pref., 438-0193, Japan, Telephone: (81)539/62-5248, Fax: (81)539/62-2205

314-5, Shimokanzo, Iwata City, Shizuoka Prer., 438-0193, Japan, 1 Elephone: (61)539/02-2249, Fax: (61)539/02-2240, Fax: (61)539/02-2240, Fax: (51)539/02-2240, Fax: (51)539/0 TPMO1057E02 NOV. 2017 IF

